



12-27-04

IFW

Atty. Dkt. No. 039153-0684 (H1719)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Xiang et al.

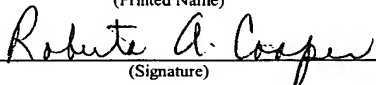
Title: A METHOD OF FABRICATING
A STRAINED SILICON
CHANNEL FINFET

Appl. No.: 10/755,763

Filing Date: 01/12/2004

Examiner: To be determined

Art Unit: 2812

CERTIFICATE OF EXPRESS MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service's "Express Mail Post Office To Addressee" service under 37 C.F.R. § 1.10 on the date indicated below and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
EV 459171045 US	12/22/04
(Express Mail Label Number)	(Date of Deposit)
Roberta A. Cooper	
(Printed Name)	
	
(Signature)	

REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST**35 U.S.C. 122(b)(2)(B)**Mail Stop PGPUB
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby rescind the previous request that the above-identified application not be published under 35 U.S.C. 122(b).

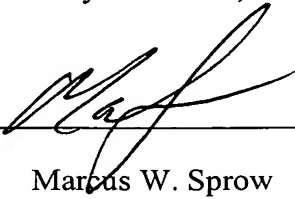
Applicant furthermore hereby provides the notice to the Patent Office required by 35 U.S.C. 122(b)(2)(B)(iii) and 37 C.F.R. 1.213(c) that an application directed to the invention disclosed in the above-identified application was submitted on December 21, 2004 in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing. This notice is being provided within forty-five days after the date of the filing of such foreign or international application.

Please direct all correspondence to the undersigned attorney or agent at the address indicated below.

Respectfully submitted,

Date 12/22/2004

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By 

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